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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yukio SAKASHITA

ATTN: Application Branch

Application No.: 10/542,956

Docket No.: 124796

Filed: July 21, 2005

For: THIN FILM CAPACITANCE ELEMENT COMPOSITION, HIGH PERMITTIVITY
INSULATION FILM, THIN FILM CAPACITANCE ELEMENT, THIN FILM
MULTILAYER CAPACITOR AND PRODUCTION METHOD OF THIN FILM
CAPACITANCE ELEMENT

FILING RECEIPT STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The above-captioned patent application was filed on July 21, 2005. A copy of the postcard receipt is attached hereto.

The original Filing Receipt has not yet been received. It is respectfully requested that the original Filing Receipt be immediately forwarded to the attorneys of record at the address set forth below.

If there are any questions regarding this matter, please contact the undersigned at the telephone number set forth below.

Respectfully submitted,

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JAO:JML/sml

Date: July 21, 2006

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PTO RECEIPT FOR FILING OF PAPER

The following papers have been filed: **JC10 Rec'd PCT/PTO 21 JUL 2005**

PCT T; Ck #168957 (\$1300); PCT Req; Prelim; International Search Report; spec
(62pgs/24clms/abst); 5pp dwgs (Figs. 1A-5)

Name of Applicant: Yukio SAKASHITA

Serial No.: New U.S. Patent Application

Atty. File No.: 124796

10/542956

Title (New Cases): THIN FILM CAPACITANCE ELEMENT COMPOSITION; HIGH PERMITTIVITY INSULATION FILM, THIN FILM CAPACITANCE ELEMENT, THIN FILM MULTILAYER CAPACITOR AND PRODUCTION METHOD OF THIN FILM CAPACITANCE ELEMENT

Sender's Initials: JAO/cqc

ASSIGNEE: TDK CORPORATION